MPI IMPACTTM Test Solutions | ITS150-TRIAX

150 mm Manual Probe System for accurate and reliable DC/CV measurements

Microscope Mount and Movement

- Stable bridge for high quality optics
- 90° tilt for easy reconfiguration
- 25 x 25 mm air bearing or optional 50 x 50 mm linear XY movement

Adjustable Platen Height

- Micrometer control for precise adjustment
- 20 mm range for various applications

Probe Platen

- · Stable and rigid design
- Supports DC/CV and RF measurements
- Rectangular adjustments for RF positioners
- Designed for maximum thermal stability

Unique Platen Lift

- Three discrete positions for contact, separation (300 μm) and safety loading (3 mm)
- Safety lock function at loading position
- "Auto Contact" position with ±1 μm repeatability for consistent contact quality

Ultra Small Footprint

- Designed for bench top use
- Comes with vibration absorber base
- Low profile design for maximum usability
- Ideal for load pull applications



Available Options

 SZ10U-ITS150
 SUPERZOOM 10X / UPGRADE ITS150

 50X50MU-ITS150
 50X50MM LINEAR MICROSCOPE MOVEMENT / UPGRADE ITS150

 MP40U-ITS
 MP40 UPGRADE IMPACT - COAX / TRIAX

 FACILITY-ITS
 FACILITY UPGRADE IMPACT / 110 - 230V

 TC-150EU-ITS
 150MM THERMAL CHUCK SYSTEM COAX / 150C / UPGR

Microscope and Optics Options

- Stereo MPI ST45
- Various optics options available
- Optional HDMI cameras, monitor user interface without computer

MicroPositioners

- Includes four MP25 DC positioners with triaxial probe arms and 2 m triaxial cables
- Supports up to 4 RF and 10 DC positioners
- Wide range of positioners available
- Optional probe arms for coaxial, Kelvin and RF measurements

Modular Chuck

- 150 mm non-thermal triaxial chuck
- Wide range of optional thermal chucks up to 300 °C
- Field upgradeable for reduced cost of ownership
- Easy switch between center and small wafer size control

Chuck XY-Theta Stage Movement

- Unique puck controlled air bearing stage for quick single-handed operation
- 180 x 230 mm XY total stage movement
- Including 25 x 25 mm fine micrometer control
- Resolution < 1.0 μm (0.04 mils) @ 500 μm/rev
- Extra wide Y-range for easy loading
- ±5° Theta fine adjustment

Front Mounted Vacuum Control

- Easy access
- · Clearly marked

The complete test package includes:

TS150 Manual Test System with puck controlled air-bearing stage

- 180 x 230 mm (7.1 x 9.1 in) XY total stage movement
- 25 x 25 mm micrometer fine stage movement
- +/- 5 degree fine chuck Theta rotation
- Platen lift with discrete contact, separation (300 μm) and loading (3 mm) positions for ease of use, safety lock function at loading position
- Dedicated 20 mm fine platen height adjustment
- Stable microscope bridge mount
- Vibration absorbing base

150 mm Triaxial Chuck, non-thermal

- · Stainless steel chuck top with vacuum rills
- Triax (female) chuck connection
- 2 m triaxial cable (male-male)

Air-Bearing Microscope Movement / 25x25 mm

- Precision 25 mm x 25 mm X-Y microscope transport
- Very easy to operate, vacuum fixation with convenient On-Off switch
- 90 degree tilt for easy and safety probe replacement or reconfiguration
- 50 mm focus block

ST45 Stereo Microscope with 6.7:1 zoom ratio

- Set of 25x eyepieces for optimal magnification
- Working distance 100 mm, C-mount adapter
- 72 LED ring illumination, four-zone selectable, external remote control
- 100-240V AC, CE

4x MP25 DC MicroPositioners for backlash-free probe positioning

- 10 mm travel range in XYZ, 500 μm screw resolution
- Universal adapter for DC arms
- Easy, convenient, and tool-less arm exchange or height adjustment
- Strong magnet base

4x Triax Probe Arms, with 2 m triaxial cables

- Ultra, low-noise triaxial cable
- · High-end triaxial connector with cable strain relief

Tungsten Probe Tips, 7 micron tip radius, one set of 25 tips Accessories, wafer tweezers, L-key set





